

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	10019	((organic or resist or photoresist) adj (layer or film)) near6 ((passivation or insulating or insulation) adj (layer or film))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/01/03 13:43
L2	908	((((organic or resist or photoresist) adj (layer or film)) near6 ((passivation or insulating or insulation) adj (layer or film)))) with (tft or "thin film transistor" or wire or drain or source)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/01/03 13:46
L3	1274	(349/43).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2006/01/03 13:45
L4	40	2 and L3	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/01/03 13:45
L5	9	(((((organic or resist or photoresist) adj (layer or film)) near6 ((passivation or insulating or insulation) adj (layer or film)))) with (tft or "thin film transistor" or wire or drain or source)) with (lift-off or (lift adj2 off))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/01/03 13:46